

08/25/2009

P/1250-293

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of:

Confirmation No.: 2987

Takushi Yoshida, et al.

Date: August 12, 2009

Serial No.: 10/541,507

Group Art Unit: 1792

Filed: July 8, 2005

Examiner: Sylvia MacArthur

For: SUBSTRATE TREATING SYSTEM, SUBSTRATE TREATING DEVICE,  
PROGRAM, AND RECORDING MEDIUM

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VIA EFS-WEB

Commissioner for Patents

P.O. Box 1450

Alexandria, VA 22313-1450

**RESPONSE TO FINAL OFFICE ACTION MAILED AUGUST 4, 2009**

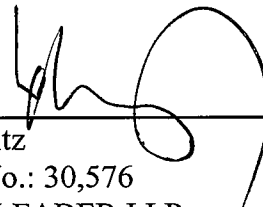
Sir:

This is responsive to the final Office Action dated August 4, 2009, which indicates that the claims distinguish over the prior art and allowance of the claims is being held up, pending receipt by the Patent Office of the promised Terminal Disclaimer. The same is enclosed herewith.

Issuance of a Notice of Allowance is earnestly solicited.

THIS CORRESPONDENCE IS BEING  
SUBMITTED ELECTRONICALLY  
THROUGH THE PATENT AND  
TRADEMARK OFFICE EFS FILING  
SYSTEM ON August 12, 2009.

Respectfully submitted,



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MM:ck  
Enclosure